

FORM PTO-1449 (Modified)	U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY.DOCKET NO. 05714 USA	SERIAL NO.
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (Use several sheets if necessary)		APPLICANT Cutler, et al.	
		FILING DATE 27 April 2001	GROUP 1745

J1016 U.S. PTO  
67109/843519  
04/27/01

## **U.S. PATENT DOCUMENTS**

## **FOREIGN PATENT DOCUMENTS**

FOREIGN PATENT DOCUMENTS													
		DOCUMENT NUMBER						DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
		YES	NO										
11	H	8	1	6	9	7	1	3	07/02/96	Japan	C01F	17/00	X
12		5	0	1	2	5	6	6	05/13/75	Japan	H01M	8/12	X
13		9	1	0	9	4	3	0	06/27/91	World	H01M	8/12	X
14		1	3	2	2	9	5	9	07/11/73	Great Britain	H01M	27/16	X
		6	2	2	8	3	1	6	1994	Japan	C08G	77/38	X

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

<i>AS</i> <i>AS</i>	<p>Chen &amp; Chen, "Grain Growth in <math>CeO_2</math>: Dopant Effects, Defect Mechanism, and Solute Drag," (J. Am. Ceram. Soc. No. 79 (1996) p. 1793) <u>no month available</u></p> <p>Baumard and coworkers, "Sintered Ceria: A New Dense and Fine Grained Ceramic Material," (J. Less Com. Metals, 127, 125-130 (1987)) <u>no month available</u></p>
------------------------	---

EXAMINER <u>Susy Tsang-Foster</u>	DATE CONSIDERED <u>3/15/03</u>
--------------------------------------	-----------------------------------

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of document with this application.